



IFW  
PATENT  
8053-1015

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

In re application of

Takekazu TANAKA

Conf. 1342

Application No. 10/602,044

Group 2814

Filed June 24, 2003

Examiner A. Chambliss

SEMICONDUCTOR PACKAGE, AND PRODUCTION  
PROCESS FOR MANUFACTURING SUCH SEMICONDUCTOR  
PACKAGE

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying document, a copy of which is attached to this statement, is made of record on the enclosed Form PTO-1449.

A concise explanation of the relevance of this item is that this reference was cited by the Japanese Patent Office in an Official Action. A copy of the Japanese Official Action in which it was cited is attached hereto, with what is believed to be the pertinent portion enclosed in a wavy line. **An English translation of the enclosed portion is also attached hereto.** JP 2000-114445 was previously cited in the Information Disclosure Statement filed March 21, 2005.

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information con-

tained in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Statement.

Respectfully submitted,

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RJP/lk

September 28, 2005



INFORMATION DISCLOSURE CITATION IN AN APPLICATION		Attorney Docket No.: <b>8053-1015</b>		Application No.: <b>10/602,044</b>			
		Applicant: <b>Takekazu TANAKA</b>					
(Use several sheets if necessary)		Filing Date: <b>June 24, 2003</b>		Group Art Unit: <b>2814</b>			
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date	Name	Class	Subclass		
FOREIGN PATENT DOCUMENTS							
Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
	JP 11-166106	06/22/1999	JAPAN (with English abstract)			<input type="checkbox"/> Yes	<input type="checkbox"/> No
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER:			DATE CONSIDERED				

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

\* Abstract provided for the Examiner's convenience